Search Notes				

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/757,638	LI ET AL.	
Examiner	Art Unit	
Michael K. Luhrs	2824	

SEARCHED					
Class	Subclass	Date	Examiner		
438	584, 597, 680, 681, 686	3/17/2005	MKL		
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INTERFERENCE SEARCHED					
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